

<b>Search Notes</b> 	<b>Application/Control No.</b>	<b>Applicant(s)/Patent under Reexamination</b>
	10/520,744	EGAWA, YOSUKE
	<b>Examiner</b> Vivian Chen	<b>Art Unit</b> 1773

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner